



ITW

Docket No.: 057454-0994

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Takeshi SATOH, et al.	:	Confirmation Number: CNF NO. 3233
	:	
Application No.: 10/750,870	:	Group Art Unit: 1755
	:	
Filed: January 05, 2004	:	Examiner: Karle E. Group
	:	
For: POROUS Si3 N4 AND PRODUCING METHOD THEREOF		

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of April 25, 2005 wherein restriction has been required, Applicant hereby elects Group I (claims 1 through 4) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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